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Bib Data Sheet

## **CONFIRMATION NO. 4741**

SERIAL NUMBEF 10/654,226	FILING DATE 09/02/2003 RULE	CLASS 445	GROUP AR 2879	OUP ART UNIT 2879		ATTORNEY DOCKET NO. 3882.8US (99- 0017.08/US)	
APPLICANTS Ammar Derraa, Boise, ID;							
** CONTINUING DATA *********************************  This application is a CON of 10/114,632 04/02/2002 PAT 6,612,891 which is a CON of 09/847,926 05/03/2001 PAT 6,398,609 which is a CON of 09/626,481 07/26/2000 PAT 6,276,982 which is a CON of 09/472,571 12/27/1999 PAT 6,133,057 which is a CON of 09/260,214 03/01/1999 PAT 6,059,625  *** FOREIGN APPLICATIONS ************************************							
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/28/2003							
Foreign Priority claimed 35 USC 119 (a-d) conditio met Verified and Acknowledged	yes no no Met aft  Allowance M/. i  Examiner's Signature Ini	STATE OR COUNTRY	SHEETS DRAWING 6	TOT CLAI	MS	INDEPENDENT CLAIMS 2	
ADDRESS 24247 TRASK BRITT P.O. BOX 2550 SALT LAKE CITY, UT 84110							
TITLE Method of fabricating field emission arrays employing a hard mask to define column lines and another mask to define emitter tips and resistors							
				All Fees  1.16 Fees (Filing)			
FILING FEE FEES: Authority has been given in Paper					1.17 Fees (Processing Ext. of		